

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM FILING DATE CLASS SUBCLASS GAU EXAMINER
10072620 02/08/2002 414 217 3652 Kramer
Bratke

**APPLICANTS: Tamagishi Takayuki; Suwada Masaei; Watanabe Takeshi;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

ASMJP.103AUS

TITLE : Semiconductor processing apparatus comprising chamber partitioned into reaction and transfer sections

U.S. DEPT. OF COM. / PAT. & TM. RTOL426L/PAW_12.943

NOTICE OF ALLOWANCE MAILED

Assistant Examiner

ISSUE FEE

Amount Due Date Paid



TERMINAL

DISCLAIMER

PREPARED FOR ISSUE

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Unauthorized disclosure may be prohibited by the United States Code Title 35,
Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark
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CLAIMS ALLOWED

Total Claims

Print Claim for
0.8

DRAWING

Sheets Drwg.

Figs.Drwg.

Print Fig.

Application Examiner

FILED WITH:



DISK (CRF)



CD-ROM

(Attached in pocket on right inside flap)